IN THE CLAIMS:

Claims 14 and 21-23 have been amended herein. Claims 13 and 30 -37 are canceled. Please note that all claims currently pending and under consideration in the referenced application are shown below. Please enter these claims as amended. This listing of claims will replace all prior versions and listings of claims in the application.

Listing of Claims:

- 1. (Original) A semiconductor circuit fuse, comprising: an insulating substrate; a refractory metal nitride layer disposed above the insulating substrate; and a tungsten silicide layer disposed over the refractory metal nitride layer.
- 2. (Original) The semiconductor circuit fuse of claim 1, wherein the insulating substrate is an isolation region.
- 3. (Original) The semiconductor circuit fuse of claim 2, wherein the isolation region is a field oxide region.
- 4. (Original) The semiconductor circuit fuse of claim 3, wherein the field oxide region is disposed on a semiconductor substrate.
- 5. (Original) The semiconductor circuit fuse of claim 4, wherein the semiconductor substrate is a silicon wafer.
- 6. (Original) The semiconductor circuit fuse of claim 1, wherein the refractory metal nitride layer and the tungsten silicide layer are configured to a similar shape.
 - 7. (Original) The semiconductor circuit fuse of claim 6, wherein the similar shape

comprises a neck portion located between terminal portions.

- 8. (Original) The semiconductor circuit fuse of claim 7, wherein the neck portion is smaller in width than the terminal portions.
- 9. (Original) The semiconductor circuit fuse of claim 8, wherein the neck portion has a width within a range of about 0.2 to about 1 micron.
- 10. (Previously presented) The semiconductor circuit fuse of claim 9, wherein the width of the neck portion is about 0.35 micron.
- 11. (Original) The semiconductor circuit fuse of claim 9, wherein a length of the neck portion is within a range of about 1 to about 10 microns.
- 12. (Original) The semiconductor circuit fuse of claim 11, wherein the length of the neck portion is about 3.5 microns.

13. (Cancelled)

- 14. (Currently amended) A semiconductor circuit fuse, comprising: an insulating substrate; a refractory metal nitride layer disposed above the insulating substrate; and a-conductive- silicide layer disposed over the refractory metal nitride layer.
- 15. (Original) The semiconductor circuit fuse of claim 14, wherein the insulating substrate is an isolation region.
- 16. (Original) The semiconductor circuit fuse of claim 15, wherein the isolation region is a field oxide region.

- 17. (Original) The semiconductor circuit fuse of claim 16, wherein the field oxide region is disposed on a semiconductor substrate.
- 18. (Original) The semiconductor circuit fuse of claim 17, wherein the semiconductor substrate is a silicon wafer.
- 19. (Original) The semiconductor circuit fuse of claim 14, wherein the refractory metal nitride layer includes titanium.
- 20. (Original) The semiconductor circuit fuse of claim 14, wherein the refractory metal nitride layer comprises titanium nitride.
- 21. (Currently amended) The semiconductor circuit fuse of claim 14, wherein the conductive silicide layer is selected from the group consisting of a metal, metal alloy and metal compound.
- 22. (Currently amended) The semiconductor circuit fuse of claim 14, wherein the conductive silicide layer comprises tungsten silicide.
- 23. (Currently amended) The semiconductor circuit fuse of claim 14,—including eonfiguring—wherein the refractory metal nitride layer and the conductive—silicide layer are configured to a similar shape.
- 24. (Original) The semiconductor circuit fuse of claim 23, wherein the similar shape comprises a neck portion located between terminal portions.
- 25. (Original) The semiconductor circuit fuse of claim 24, wherein the neck portion is smaller in width than the terminal portions.
 - 26. (Original) The semiconductor circuit fuse of claim 25, wherein the neck portion

has a width within a range of about 0.2 to about 1 micron.

- 27. (Previously presented) The semiconductor circuit fuse of claim 26, wherein the width of the neck portion is about 0.35 micron.
- 28. (Original) The semiconductor circuit fuse of claim 27, wherein a length of the neck portion is within a range of about 1 to about 10 microns.
- 29. (Original) The semiconductor circuit fuse of claim 28, wherein the length of the neck portion is about 3.5 microns.
 - 30.-37. (Cancelled)